

<b>Notice of References Cited</b>	Application/Control No. 10/564,236		Applicant(s)/Patent Under Reexamination SOLO DE ZALDIVAR, JOSE	
	Examiner Vicki B. Booker		Art Unit 2813	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-5,087,578	02-1992	Endo et al.	438/309
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	D	US-			
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	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Van Zant, Peter; "Microchip Fabrication - A Practical Guide to Semiconductor Processing"; 2004; The McGraw-Hill Companies, Inc.; Fifth Edition; Pages 369 - 381.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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